

Notice of References Cited	Application/Control No. 10/653,754		Applicant(s)/Patent Under Reexamination MEIER ET AL.	
	Examiner Daniel Kim		Art Unit 2185	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,490,654	12-2002	Wickeraad et al.	711/133
*	B	US-2002/0188806	12-2002	Rakvic et al.	711/119
*	C	US-6,584,546	06-2003	Kavipurapu, Gautam Nag	711/120
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	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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